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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Wai-Fan Yau, et al.

Serial No.: 10/756,122

Confirmation No.: 4554

Filed: January 13, 2004

For: Low Dielectric Constant
Film Produced from Silicon
Compounds Comprising
Silicon-Carbon Bond

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Group Art Unit: 2823

Examiner: Julio J. Maldonado

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING	
37 CFR 1.8	
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<u>7/6/07</u>	<u><i>Keith M. Tackett</i></u>
Date	Keith M. Tackett

Dear Sir:

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

The Applicants, and the Attorney who signs below on the basis of the information supplied by the inventor and the information in his file, submit herewith patents, publications, or other information of which they are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

While the information submitted in this Supplemental Information Disclosure Statement may be material pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that any patent, publication, or other information referred to therein is prior art for this invention unless specifically designated as such.

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The patents and/or publications submitted herewith are set forth on the attached Form PTO-SB08a and SB08b. Copies of the US references are not being submitted.

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Respectfully submitted,



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**SUPPLEMENTAL
INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Sheet 1 of 1

Complete if Known

Application Number	10/756,122
Filing Date	January 13, 2004
First Named Inventor	Wai-Fan Yau, et al.
Art Unit	2823
Examiner Name	Julio J. Maldonado
Attorney Docket Number	APPM/002592.C7/DSM/LOW K/JP

NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	C1	Extended European Search Report dated June 6, 2007 for European Application No. 05014450.0. (APPM/002592.EP D1)	
	C2	Bakli et al., "Materials and Processing for 0.25 mum Multilevel Interconnect" Microelectronic Engineering, Elsevier Publishers BV., Amsterdam, NL, Vol. 33, No. 1, January 1997, pp. 175-188.	

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.

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